



MICRON.240A

COPY OF PAPERS
ORIGINALLY FILED

77 Amcl + A
9-10-02
JD

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Ammar Derraa et al.
Appl. No. : 09/944,903
Filed : August 30, 2001
For : HIGH ASPECT RATIO
CONTACT STRUCTURE
WITH REDUCED SILICON
CONSUMPTION

) Group Art Unit 2826

) I hereby certify that this correspondence and all
) marked attachments are being deposited with the
) United States Postal Service as first-class mail in
) an envelope addressed to: United States Patent
) and Trademark Office, P.O. Box 2327, Arlington,
) VA 22202, on

August 19, 2002

(Date)

Linda H. Liu, Reg. No. 51,240

RECEIVED
SEP - 3 2002
TECHNOLOGY CENTER-2800

Examiner : Victor A. Mandala

RESPONSE TO RESTRICTION REQUIREMENT

United States Patent and Trademark Office
P.O. Box 2327
Arlington, VA 22202

Dear Sir:

In response to the Office Action mailed August 2, 2002, please amend the above captioned application as follows:

IN THE CLAIMS

Please cancel Claims 19-26 without prejudice.

REMARKS

In the Office Action, the Examiner imposed a restriction requirement on the above-captioned application under 35 U.S.C. §121 and requested the Applicant to elect the invention to be examined. Pursuant to the Examiner's request, Applicant hereby elects to restrict the above-captioned application to Claims 1-18 without traverse and cancels Claims 19-26 without prejudice. Applicant respectfully submits that the application is now in compliance with 35 U.S.C. §121. Hence, reconsideration of the above-captioned application in light of the amendments and remarks contained herein is respectfully requested. Please charge any additional

Appl. No. : 09/944,903
Filed : August 30, 2001

fees, including any fees for additional extension of time, or credit overpayment to Deposit Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 8/19/2002

By: 

Linda H. Liu

Registration No. 51,240

Attorney of Record

2040 Main Street, 14th Floor

Irvine, CA 92614

(909) 781-9231

R:\DOCS\LHL\LHL-3960.DOC
081902

COPY OF PAPERS
ORIGINALLY FILED

PATENT

Case Docket No. MICRON.240A

Date: August 19, 2002

Page 1

In re application of : Ammar Derraa et al.

App. No. : 09/944,903

Filed : August 30, 2001

For : HIGH ASPECT RATIO
CONTACT STRUCTURE
WITH REDUCED SILICON
CONSUMPTION

Examiner : Victor A. Mandala

Art Unit : 2826

I hereby certify that this correspondence and all marked attachments
are being deposited with the United States Postal Service as first class
mail in an envelope addressed to: United States Patent and Trademark
Office, P.O. Box 2327, Arlington, VA 22202, on

August 19, 2002

(Date)

Linda H. Liu, Reg. No. 51,240

RECEIVED
SEP - 3 2002
TECHNOLOGY CENTER 2800

UNITED STATES PATENT AND TRADEMARK OFFICE
P.O. Box 2327
Arlington, VA 22202

ATTN: BOX NO FEE AMENDMENT

Sir:

Transmitted herewith is a Response to Restriction Requirement in the above-identified application.

The fee has been calculated as shown below:

CLAIMS AS FILED

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
Total Claims	18	26	= 0 ×	\$18	= \$0
Independent Claims	2	3	= 0 ×	\$84	= \$0
If application has been amended to contain multiple dependent claim(s), then add				\$280	= \$0
Time Extension Fee					\$0
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0

(X) Return prepaid postcard.

(X) Please charge any additional fees, including any fees for additional extension of time, or credit
overpayment to Deposit Account No. 11-1410.

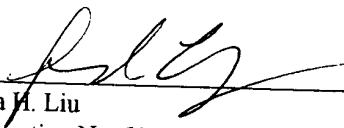
PATENT

Case Docket No. MICRON.240A

Date: August 19, 2002

Page 2

(X) Please use Customer No. 20,995 for the correspondence address.



Linda H. Liu
Registration No. 51,240
Attorney of Record
Customer No. 20,995

R:\DOCS\LHL\LHL-3962.DOC
081902